



*Copy 12/29/98*

Docket: 0756-958

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
SHUNPEI YAMAZAKI et al. )  
Serial No. 08/183,800 ) Art Unit: 2811  
Filed: 01/21/94 ) Examiner: S. Crane  
For: SEMICONDUCTOR MATERIAL AND )  
METHOD FOR FORMING THE SAME AND )  
THIN FILM TRANSISTOR )

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited  
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Commissioner For Patents Washington, D.C. 20231, on  
12-29-98

*James L. Lipton*

AMENDMENT

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the *Office Action* mailed on September 29, 1998, please  
amend the above-identified application as follows:

01/11/1999 ZABDALLA 00000035 08183800

01 FC:103

126.00 OP

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*#47  
Amend  
J. McMillan  
2/18/99*

*L*